

<b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b>				Docket No. <b>BUR920030189US1</b>
Applicant(s): <b>Anthony J. Stamper</b>				
Application No. <b>10/709,722</b>	Filing Date <b>5/25/2004</b>	Examiner <b>Chu, Chris C.</b>	Group Art Unit <b>2815</b>	
<b>Invention: METHOD OF FORMING A SEMICONDUCTOR DEVICE HAVING AIR GAPS AND THE STRUCTURE SO FORMED</b>				
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I hereby certify that this <u>Request for Reconsideration (13 pages)</u> <small>(Identify type of correspondence)</small> is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u> )				
on <u>2/2/2006</u> <small>(Date)</small>	<u>Kim Dwileski</u> <small>(Typed or Printed Name of Person Signing Certificate)</small>  <small>(Signature)</small>			
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**DOCKET NO.: BUR920030189US1**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Anthony K. Stamper

Examiner: Chu, Chris C.

Serial No.: 10/709,722

Art Unit: 2815

Filed: 05/25/2004

**Title: METHOD OF FORMING A SEMICONDUCTOR DEVICE HAVING AIR GAPS  
AND THE STRUCTURE SO FORMED**

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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**REQUEST FOR RECONSIDERATION**

Sir:

This Request for Reconsideration is in response to the Final Office Action mailed December 16, 2005.

10/709,722

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